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DISPLAY DEVICE

Abstract

A display device includes a substrate, a first inorganic layer disposed on the substrate, a transistor disposed on the first inorganic layer, a first organic layer disposed on the transistor and including a contact via, a light emitting diode including an anode, a cathode, and a light emitting layer disposed therebetween, a first sealing layer disposed on the light emitting diode, a first conductor disposed between the substrate and the first sealing layer, and a second conductor disposed on the substrate. The transistor includes a semiconductor, a first electrode and a second electrode. The anode is electrically connected with the second electrode through the contact via. The first conductor is electrically connected to the light emitting diode. The first conductor is disposed in the display area, the second conductor is disposed in the non-display area, and the first conductor is electrically connected to the second conductor.

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Background/Summary

CROSS REFERENCE TO RELATED APPLICATIONS [0001] This application is a continuation application of U.S. application Ser. No. 18/120,418, filed on Mar. 12, 2023, which is a continuation application of U.S. application Ser. No. 17/105,532, filed on Nov. 26, 2020, which claims the benefit of U.S. Provisional Application No. 62/953,464, filed on Dec. 24, 2019. The contents of these applications are incorporated herein by reference.

BACKGROUND OF THE DISCLOSURE

1. Field of the Disclosure

[0002] The present disclosure relates to a display device, and more particularly to a display device with a light emitting diode.

2. Description of the Prior Art

[0003] In an electronic (display) device, a capacitor is provided so that a thin film transistor may have a stable voltage during the operation of each frame. If the space for a capacitor is too limited to have the needed capacitance value, the brightness uniformity of the display may be affected. In addition, when a transparent conductive material is used in the cathode of an organic light emitting diode, the higher impedance of the transparent conductive material affects the voltage distribution, and the insufficient voltage causes IR drop. Some electronic devices are equipped with auxiliary electrodes to reduce the aforementioned IR drop problem. However, under the coexistence of capacitors and auxiliary electrodes, an interference may occur between the capacitor and the auxiliary electrode. The interference need to be improved.

SUMMARY OF THE DISCLOSURE

[0004] In view of this, the present disclosure proposes a display device to solve the technical problems in the field.

[0005] According to an embodiment of the present disclosure, a display device has a display area and a non-display area, and includes a substrate, a first inorganic layer disposed on the substrate, a transistor, a first organic layer disposed on the transistor and including a contact via, a light emitting diode, a first sealing layer, a first conductor and a second conductor. The transistor is disposed on the first inorganic layer, and includes a semiconductor, a first electrode overlapping the semiconductor, and a second electrode electrically connected with the semiconductor. The light emitting diode includes an anode, a cathode, and a light emitting layer disposed therebetween. The light emitting layer is electrically connected with the anode and the cathode. The anode is electrically connected with the second electrode through the contact via. The first sealing layer is disposed on the light emitting diode. The first conductor is disposed between the substrate and the first sealing layer and electrically connected to the light emitting diode. The second conductor is disposed on the substrate. The first conductor is disposed in the display area, the second conductor

is disposed in the non-display area, and the first conductor is electrically connected to the second conductor.

[0006] These and other objectives of the present disclosure will no doubt become obvious to those of ordinary skill in the art after reading the following detailed description of the embodiment that is illustrated in the various figures and drawings.

Description

BRIEF DESCRIPTION OF THE DRAWINGS

[0007] FIG. 1A, FIG. 1B, and FIG. 1C are schematic diagrams of cross-sectional structures of the display device in different manufacturing stages according to the first embodiment of the present disclosure.

[0008] FIG. 2A and FIG. 2B are schematic diagrams of the cross-sectional structures of the display device according to the second embodiment of the present disclosure.

[0009] FIG. 3 is a schematic diagram of a cross-sectional structure of a display device according to a third embodiment of the present disclosure.

[0010] FIG. 4A and FIG. 4B are schematic diagrams of the cross-sectional structures of the display device in different manufacturing stages according to the fourth embodiment of the present disclosure.

[0011] FIG. 5 is a schematic diagram of a cross-sectional structure of a display device according to a fifth embodiment of the present disclosure.

[0012] FIG. 6 is a schematic diagram of a cross-sectional structure of a display device according to a sixth embodiment of the present disclosure.

[0013] FIG. 7 is a schematic diagram of the cross-sectional structure of the display device in the manufacturing stages according to the seventh embodiment of the present disclosure.

[0014] FIG. 8 is a schematic diagram of a cross-sectional structure of the display device in the manufacturing stages according to the eighth embodiment of the present disclosure.

[0015] FIG. 9 is a schematic diagram of the cross-sectional structure of the display device in the manufacturing stages according to the ninth embodiment of the present disclosure.

[0016] FIG. 10 is a schematic diagram of the cross-sectional structure of the display device in the manufacturing stages according to the tenth embodiment of the present disclosure.

[0017] FIG. 11 is a schematic diagram of the cross-sectional structure of the display device in the manufacturing stages according to the eleventh embodiment of the present disclosure.

[0018] FIG. 12 is a schematic diagram of the cross-sectional structure of the display device including a display area and a non-display area according to a twelfth embodiment of the present disclosure.

[0019] FIG. 13A is a schematic diagram of NMOS type circuit of the display device according to an embodiment of the present disclosure

[0020] FIG. 13B is a schematic diagrams of PMOS type circuit of the display device according to an embodiment of the present disclosure.

DETAILED DESCRIPTION

[0021] The present disclosure may be understood by reference to the following detailed description, taken in conjunction with the drawings as described below. It is noted that, for purposes of illustrative clarity and being easily understood by the readers, various drawings of this disclosure show a portion of the touch display device, and certain elements in various drawings may not be drawn to scale. In addition, the number and dimension of each device shown in drawings are only illustrative and are not intended to limit the scope of the present disclosure. In addition, similar and/or corresponding numeral references may be used in different embodiments. They are used for a simple and clear description of some embodiments, and do not imply that there

is any connection between the different embodiments and/or structures discussed.

[0022] Certain terms are used throughout the description and following claims to refer to particular components. As one skilled in the art will understand, electronic equipment manufacturers may refer to a component by different names. This document does not intend to distinguish between components that differ in name but not function. In the following description and in the claims, the terms “include”, “comprise” and “have” are used in an open-ended fashion, and thus should be interpreted to mean “include, but not limited to”.

[0023] The directional terms mentioned in this article, such as “on”, “below”, “front”, “rear”, “left”, “right”, etc., only refer to the directions of the drawings. In the drawings, each drawing depicts the general features of the methods, structures and/or materials used in specific embodiments. However, these drawings should not be construed as defining or limiting the scope or nature in these embodiments. For example, in terms of clarity, the relative size, thickness, and position of each layer, region, and/or structure may be reduced or enlarged.

[0024] The terms “about”, “substantially”, “equal”, or “same” generally mean within 20% of a given value or range, or mean within 10%, 5%, 3%, 2%, 1%, or 0.5% of a given value or range.

[0025] Although terms such as first, second, third, etc., may be used to describe diverse constituent elements, such constituent elements are not limited by the terms. The terms are used only to discriminate a constituent element from other constituent elements in the specification. The claims may not use the same terms, but instead may use the terms first, second, third, etc. with respect to the order in which an element is claimed. Accordingly, in the following description, a first constituent element may be a second constituent element in a claim.

[0026] In this disclosure, the thickness, the length and the width may be measured by using an optical microscope, and the thickness may be measured by a cross-sectional image in an electron microscope, but the present disclosure is not limited thereto. In addition, there may be a certain error between any two values or directions used for comparison. If the first value is equal to the second value, it implies that there may be an error of about 10% between the first value and the second value. If the first direction is perpendicular to the second direction, the angle between the two may be between 80 degrees and 100 degrees. If the first direction is parallel to the second direction, the angle between the first direction and the second direction may be between 0 degree and 10 degrees. Unless otherwise defined, all terms (including technical terms and scientific terms) used herein have the same meanings as commonly understood by those persons having ordinary skill in the art to which this disclosure belongs. It is understandable that these terms, such as those defined in commonly used dictionaries, should be interpreted as having meanings consistent with the relevant technology and the background or context of this disclosure, and should not be interpreted in an idealized or excessively formal way unless they are specifically defined in the embodiments of the present disclosure.

[0027] When a component or a film layer is referred to as “disposed on another component or another film layer” or “connected to (or with) another component or another film layer”, it can mean that the component or film layer is directly disposed on another component or film layer, or directly connected to (or with) another component or film layer, or there may be other components or film layers in between. In contrast, when a component is said to be “directly disposed on another component or film” or “directly connected to (or with) another component or film”, there is no component or film between the two.

[0028] It should be noted that the technical solutions provided by the different embodiments below may be used interchangeably, combined or mixed to form another embodiment without violating the gist of the disclosure. When a part (or a film layer) overlaps another part (or another film layer), it means that a part (or a film layer) and another part (or another film layer) are in the upper direction Overlapped.

[0029] FIG. 1A, FIG. 1B, and FIG. 1C are schematic diagrams of cross-sectional structures of the display device **100** in different manufacturing stages according to the first embodiment of the

present disclosure. The display device **100** may include a substrate **101**, a thin film transistor **120**, a storage capacitor **130**, and a blue organic light emitting diode **150**, but the present disclosure is not limited thereto. The display device **100** may include a first inorganic layer **110**, a first organic layer **140**, a first sealing layer **160**, a wavelength conversion element **166**, a blue light blocking element **170**, and a second sealing layer **179**. The electronic device may include a display device, an antenna device, a sensing device, a light emitting device and/or a tiling type device, but the present disclosure is not limited thereto. The display device **100** may include a bendable or flexible device. The display device **100** may include an organic light emitting diode (OLED), a quantum dot light emitting diode (such as QLED or QDLED), fluorescence, phosphor, other suitable materials or a combination thereof, but the present disclosure is not limited thereto. The substrate **101** may include a substrate layer. For example, the substrate **101** may include a hard substrate or a flexible substrate. The materials of the substrate **101** may include glass, ceramic, polyimide (PI) or polyethylene terephthalate (PET), other suitable materials or a combination thereof, but the present disclosure is not limited thereto.

[0030] In some embodiments, the first inorganic layer **110** may be disposed on the substrate **101** and the thin film transistor **120** may be disposed on the first inorganic layer **110**. It should be noted that “the thin film transistor **120** is disposed on the first inorganic layer **110**” refers to that one of the components of the thin film transistor **120** may be disposed on the first inorganic layer **110**.

[0031] In some embodiments, the first inorganic layer **110** may be a single material layer, and other layers may be selectively provided between the first inorganic layer **110** and the substrate **101**, or the first inorganic layer **110** may directly contact the substrate **101**. In some embodiments, the thin film transistor **120** may be a switching element, a driving element or a transistor with other functions, but the present disclosure is not limited thereto. The thin film transistor **120** may include a metal oxide semiconductor **121**, a gate electrode **122** overlapping the metal oxide semiconductor **121**, a source electrode **124** and a drain electrode **123** which may be electrically connected with the metal oxide semiconductor **121**, but the present disclosure is not limited thereto. The metal oxide semiconductor **121** may include an indium gallium zinc oxide (IGZO), other suitable materials, or a combination thereof, but the present disclosure is not limited thereto. The metal oxide semiconductor **121** may be defined to be a channel. In the top view direction **D1** (the normal direction of the surface of the substrate **101**), the metal oxide semiconductor **121** at least partially overlaps the gate electrode **122**, and a dielectric material may be provided (or disposed) between the metal oxide semiconductor **121** and the gate electrode **122** as a gate dielectric layer. The gate dielectric layer may be the second inorganic layer **112**, but is not limited to this, and may be optionally adjusted. The structure of the thin film transistor in the present disclosure is for example only, and the types or structures of the thin film transistor may be optionally adjusted. In some embodiments, the storage capacitor **130** may include a first electrode **131** and a second electrode **132**. The first electrode **131** may be electrically insulated from the second electrode **132** and overlap with the second electrode **132**. The first electrode **131** may be electrically connected with the gate electrode **122**; the second electrode **132** may be electrically connected with the source electrode **123**. Specifically speaking, a dielectric material layer may be provided (or disposed) between the first electrode **131** and the second electrode **132** so that the first electrode **131** may be electrically insulated from the second electrode **132**. In the embodiment, the dielectric material layer may include a third inorganic layer **113**, but the present disclosure is not limited thereto. In some embodiments, in the top view direction **D1**, the first electrode **131** and the second electrode **132** may completely overlap or partially overlap with each other. The materials of the first inorganic layer **110**, the second inorganic layer **112** and/or the third inorganic layer **113** may include insulating materials, such as silicon nitride, silicon oxide, silicon oxynitride, other suitable materials or a combination thereof, but the present disclosure is not limited thereto. The first inorganic layer **110**, the second inorganic layer **112**, and/or the third inorganic layer **113** may include the same material or different materials. In other embodiments (not shown), the second

electrode **132** may be electrically connected to the drain electrode **123**. In some embodiments (as shown in FIG. **1A**), the first electrode **131** and the gate electrode **122** may be formed of the same conductive layer, and the second electrode **132**, the source electrode **124** and/or drain electrode **123** may be formed of the same conductive layer, but it is not limited thereto.

[0032] In some embodiments, the first organic layer **140** may be disposed on the thin film transistor **120** and may include a contact via **141**. The contact via **141** may partially overlap the thin film transistor **120** (such as the source electrode **124**, but not limited thereto). In some embodiments, the first organic layer **140** may be a planarization layer. As shown in FIG. **1A**, the second inorganic layer **112** may be disposed between the gate electrode **122** and the metal oxide semiconductor **121**, and the third inorganic layer **113** may be disposed between the source electrode **124** (and/or the drain electrode **123**) and the gate electrode **122**. In some embodiments, the first electrode **131** of the storage capacitor **130** may be disposed between the second inorganic layer **112** and the third inorganic layer **113**, and the second electrode **132** of the storage capacitor **130** may be disposed between the third inorganic layer **113** and the first organic layer **140**, but it is not limited thereto. It should be noted that the positions of the first electrode **131** and the second electrode **132** may be interchanged. In some embodiments, the blue organic light emitting diode **150** may include an anode **151**, a cathode **152**, and a blue organic light emitting layer **153** disposed therebetween, and the blue organic light emitting layer **153** may be electrically connected to the anode **151** and to the cathode **152**. In some embodiments, the anode **151** may be electrically connected to the source electrode **124** through the contact via **141**, but the present disclosure is not limited thereto. In some embodiments (not shown), the anode **151** may be electrically connected to one of the source electrode **124** and the drain electrode **123**. In some embodiments, the main wavelength of the emission spectrum of the blue organic light emitting layer **153** may be between 400 nm (nanometer) and 490 nm ($400\text{ nm} \leq \text{main wavelength} \leq 490\text{ nm}$), but it is not limited thereto. In some embodiments (not shown), the blue organic light emitting layer **153** may include a hole injection layer (HIL), a hole transport layer (HTL), a light emission layer (EL), an electron transport layer (ETL), an electron injection layer (EIL) and/or charge generation layer (CGL), but it is not limited thereto. In some embodiments, although only one blue organic light emitting diode **150** is illustrated in FIGS. **1B** and **1n** FIG. **1C**, the display device **100** may include a plurality of blue organic light emitting diodes **150**, and the cathode **152** may be used as a common cathode layer of a plurality of blue organic light emitting diodes **150**, but it is not limited thereto. In some embodiments, the first sealing layer **160** may be disposed on the blue organic light emitting diode **150**. The first sealing layer **160** may include a transparent material, an organic or inorganic insulating layer material, but it is not limited thereto. The first sealing layer **160** may have moist-proof, filling and/or covering properties, but it is not limited thereto. In some embodiments, the refractive index of the first sealing layer **160** and the refractive index of the adjacent layer may match to facilitate blue light emission. The first sealing layer **160** may include a single layer or a composite layer, such as a stacking layer of the inorganic layer **161**, the organic layer **162** and the inorganic layer **163** (IOI), but it is not limited thereto. The wavelength conversion element **166** may be disposed on the first sealing layer **160**. The wavelength conversion element **166** may convert blue light into wavelength light of other colors, such as green light, red light or light of other suitable color, but it is not limited thereto. The wavelength conversion element **166** may include quantum dots, phosphor materials, fluorescence materials, pigments, dyes, scattering particles, filter layers, other suitable materials or a combination thereof, but it is not limited thereto. The blue blocking element **170** may be disposed on the wavelength conversion element **166** to block, absorb or filter the light which is not converted by the wavelength conversion element **166** to improve the color quality of the output light. It should be noted that the display device **100** may include a plurality of sub-pixels, and each sub-pixel may correspond to a blue organic light emitting diode **150**. When the sub-pixel is a red sub-pixel or a green sub-pixel, the wavelength conversion element **166** which corresponds to the organic light emitting diode **150** in the sub-pixel may convert the

blue light emitted by the blue organic light emitting diode **150** into red light or green light, but it is not limited thereto. When the sub-pixel is a blue sub-pixel, the blue blocking layer **170** and/or the wavelength conversion element **166** may optionally not be provided (or disposed) on the blue organic light emitting diode **150** in the sub-pixel, or these two layers may be replaced with other transparent filling layers, but it is not limited thereto. In addition, the second sealing layer **179** may be disposed on the blue light blocking element **170** to protect the layers below the second sealing layer **179**. In some embodiments, the second sealing layer **179** may include an organic insulating layer or an inorganic insulating layer, but it is not limited thereto. In some embodiments, if the second sealing layer **179** is the outermost layer, the second sealing layer **179** may optionally include a protective cover. The protective cover may have a protective or scratch-resistant function.

[0033] The manufacturing process of the display device **100** of the first embodiment is briefly described as follows, but it is not limited thereto. Please refer to FIG. **1A**, a first inorganic layer **110** and a metal oxide semiconductor layer (not shown) may be disposed on a substrate **101**, and the metal oxide semiconductor layer may be patterned to obtain a metal oxide semiconductor **121**. Next, a second inorganic layer **112** and a first conductive layer (not shown) may be disposed on the first inorganic layer **110**, and the first conductive layer may be patterned to obtain the first electrode **131** and the gate electrode **122**, but it is not limited thereto. In other words, the first electrode **131** and the gate electrode **122** may be formed of the same conductive layer. The above configuration may simplify the manufacturing process. Then, a third inorganic layer **113** may be disposed on the second inorganic layer **112**, and the third inorganic layer **113** may be patterned to obtain a first conductive via **114** and a second conductive via **115**. Next, a second conductive layer (not shown) may be disposed on the third inorganic layer **113**, and the second conductive layer may be patterned to obtain the second electrode **132**, the source electrode **124** and/or the drain electrode **123**, and a portion of the source electrode **124** may be disposed in the first conductive via **115**, a portion of the drain electrode **123** may be disposed in the second conductive via **114**, but it is not limited thereto. In other words, the second electrode **132**, the source electrode **124**, and/or the drain electrode **123** may be formed of the same conductive layer, and the above configuration may simplify the manufacturing process. In some embodiments, the thin film transistor **120** may include a metal oxide semiconductor **121**, a gate electrode **122**, a source electrode **124**, a drain electrode **123** and a portion of the second inorganic layer **112**, but it is not limited thereto. In some embodiments, the storage capacitor **130** may include a first electrode **131**, a second electrode **132** and a portion of the third inorganic layer **113**, but it is not limited thereto. The dielectric layer (for example, the third inorganic layer **113**) disposed between the first electrode **131** and the second electrode **132** of the storage capacitor **130** may be optionally adjusted. In some embodiments, in the top view direction **D1**, the storage capacitor **130** may not overlap the thin film transistor **120** to reduce the interference between the storage capacitor **130** and the thin film transistor **120**.

[0034] Please refer to FIG. **1B**, a first organic layer **140** may be disposed on the thin film transistor **120**. The first organic layer **140** may be used as a planarization layer, and the first organic layer **140** may be patterned to form a contact via **141**. Then, a third conductive layer (not shown) may be disposed on the first organic layer **140**, a portion of the third conductive layer may be filled in the contact via **141**, and then the third conductive layer may be patterned to obtain an anode **151** of the blue organic light emitting diode **150**. Next, a patterned second organic layer **142** may be disposed to expose a portion of the anode **151**, and the patterned second organic layer **142** may be used as a pixel definition layer (PDL). Then, the blue organic light emitting layer **153** and the cathode **152** may be disposed to complete the production of the blue organic light emitting diode **150**. Later, the first sealing layer **160** may be disposed on the blue organic light emitting diode **150**. In some embodiments, the auxiliary electrode **155** may be selectively disposed in the structure shown in FIG. **1B**. For the details of the auxiliary electrode **155**, please refer to the descriptions in the subsequent embodiments.

[0035] Next, referring to FIG. **1C**, a second substrate structure **102** may be formed. In some

embodiments, the second substrate structure **102** may include a composite laminated structure. For example, the second substrate structure **102** may include a second sealing layer **179**, a light shielding layer **173**, a blue light blocking element **170**, a wavelength conversion element **166**, an insulating layer **171** and/or a planarization layer **172**, but it is not limited thereto. In other embodiments, other elements may be selectively added to the second substrate structure **102** or the aforementioned elements may be selectively removed. In some embodiments, the planarization layer **172** may include a transparent material, the refractive index of the planarization layer **172** and the refractive index of an adjacent layer may match to facilitate the light emission. In some embodiments, the planarization layer **172** may include an organic material, but it is not limited thereto. In some embodiments, the materials of the light shielding layer **173** may include a black photoresist, a black resin, other suitable materials or a combination thereof, but it is not limited thereto. In some embodiments, the second substrate structure **102** may be formed with reference to the following descriptions. For example, a patterned light shielding layer **173** may be disposed on the second sealing layer **179** (such as a base plate). In the top view direction **D1**, the pattern of the light-shielding layer **173** may not overlap the blue organic light emitting diode **150** (that is, misaligned with each other), and the openings **O** between the patterns of the light-shielding layer **173** may be selectively disposed with the blue light blocking element **170** and/or the wavelength conversion element **166**. The blue light blocking element **170** may be disposed between the second sealing layer **179** and the wavelength conversion element **166**, but it is not limited thereto. Next, an insulating layer **171** may be disposed to cover the light shielding layer **173**, the blue blocking element **170** and/or the wavelength conversion element **166**. Then, a planarization layer **172** may be disposed on the insulating layer **171**, so that the second substrate structure **102** may have a flat surface to facilitate the subsequent attachment to the substrate **101** with the layers disposed on the substrate **101**. Later, the second substrate structure **102** is attached to the substrate **101**. After the attachment is completed, in the top view direction **D1**, the wavelength conversion element **166** may roughly overlap the blue organic light emitting diode **150**, the term “overlap” includes partial overlap and complete overlap. A filling layer **174** may be selectively disposed between the second substrate structure **102** and the substrate **101**, and the filling layer **174** may include an adhesive material to attach the second substrate structure **102** to the substrate **101**, to reduce the offset problem between second substrate structure **102** and the substrates **101**. After the second substrate structure **102** and the substrate **101** are aligned and attached, the display device **100** of the first embodiment shown in FIG. **1C** may be obtained. In some embodiments, the filling layer **174** may include an optically functional layer to guide the light emitted by the blue organic light emitting diode **150** to the wavelength conversion element **166** to improve light efficiency, but it is not limited thereto.

[0036] The display device of the present disclosure is not limited to the above-mentioned embodiments. Other embodiments of the present disclosure are described as follows. In order to simplify the descriptions and highlight the differences between the embodiments, the same reference numerals may be used to label the same elements in the following, and similar descriptions may be omitted. In addition, please refer to the above embodiments for the conditions of each film, layers, materials and process steps in the subsequent embodiments, and they will not be elaborated again.

[0037] FIG. **2A** and FIG. **2B** are schematic diagrams of the cross-sectional structures of the display device **100** according to the second embodiment of the present disclosure. Compared with the first embodiment, the main difference between the second embodiment and the first embodiment resides in the different configuration of the stack structure including the storage capacitor **130**. For example, the first electrode **131** of the storage capacitor **130** of the second embodiment may be disposed between the substrate **101** and the first inorganic layer **110**. The first electrode **131** and the shielding metal layer **131-1** may be formed of the same conductive layer, but it is not limited thereto. The second electrode **132** of the storage capacitor **130** of the second embodiment may be

disposed between the third inorganic layer **113** and the first organic layer **140**, and the second electrode **132** and the source electrode **124** and/or the drain electrode **123** may be formed of the same conductive layer, but it is not limited thereto. It should be noted that it is not limited to this only although the second electrode **132** is illustrated to be disposed on the first electrode **131** in the embodiment. In other embodiments, the positions of the first electrode **131** and the second electrode **132** may be optionally interchanged. In other words, the second electrode **132** of the storage capacitor **130** may be disposed between the substrate **101** and the first inorganic layer **110**, and the first electrode **131** of the storage capacitor **130** may be disposed between the third inorganic layer **113** and the first organic layer **140**. In some embodiments, the first inorganic layer **110**, the second inorganic layer **112**, and/or the third inorganic layer **113** may be disposed between the first electrode **131** and the second electrode **132** to serve as the dielectric layer of the storage capacitor **130**, but it is not limited thereto. In some embodiments, the shielding metal layer **131-1** may be used to block or shield the light coming from the bottom side of the substrate **101** to reduce the adverse effects of the backside light on the thin film transistor **120**, or to reduce the damages of the elements of the display device **100** caused by static electricity, but it is not limited thereto.

[0038] The manufacturing process of the display device **100** of the second embodiment will be briefly described as follows, but it is not limited thereto. Please refer to FIG. 2A, a first conductive layer (not shown) may be disposed on the substrate **101**, and the first conductive layer may be patterned to obtain the first electrode **131** and the shielding metal layer **131-1**. In other words, the first electrode **131** and the shielding metal layer **131-1** may be formed of the same conductive layer. Next, the first inorganic layer **110** may be disposed on the first electrode **131** and the shielding metal layer **131-1**, the first electrode **131** and the shielding metal layer **131-1** may be disposed between the substrate **101** and the first inorganic layer **110**. Then, as described above, the thin film transistor **120**, other layers of the storage capacitor **130** (such as the second electrode **132**), the blue organic light emitting diode **150**, the inorganic insulating layer and/or the organic insulating layer are completed on the substrate **101**. In this embodiment, please refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (please refer to FIG. 1C) is aligned and attached to the substrate **101** of the second embodiment, the display device **100** of the second embodiment as shown in FIG. 2B may be obtained.

[0039] FIG. 3 is a schematic diagram of a cross-sectional structure of a display device **100** according to a third embodiment of the present disclosure. Compared with the first embodiment, the main difference between the third embodiment and the first embodiment resides in the different configuration of the stack structure of the storage capacitor **130**, so similar structures will not be elaborated again. For example, the second electrode **132** may be disposed between the second inorganic layer **112** and the third inorganic layer **113**. The second electrode **132** and the gate electrode **122** may be formed of the same conductive layer. In some embodiments, the first inorganic layer **110** and the second inorganic layer **112** may be disposed between the first electrode **131** and the second electrode **132** to serve as the dielectric layer of the storage capacitor **130**. In some embodiments, the positions of the second electrode **132** and the first electrode **131** may be interchanged. In other words, the second electrode **132** of the storage capacitor **130** may be disposed between the substrate **101** and the first inorganic layer **110**, and the first electrode **131** of the storage capacitor **130** may be disposed between the second inorganic layer **112** and the third inorganic layer **113**.

[0040] The manufacturing process of the display device **100** of the third embodiment will be briefly described as follows, but it is not limited thereto. Please refer to FIG. 3, a conductive layer (not shown) may be disposed on the substrate **101**, and the conductive layer may be patterned to obtain the first electrode **131** and the shielding metal layer **131-1**. In other words, the first electrode **131** and the shielding metal layer **131-1** may be formed of the same conductive layer. Next, a first inorganic layer **110** may be disposed on the first electrode **131** and the shielding metal layer **131-1**.

The first electrode **131** and the shielding metal layer **131-1** may be disposed between the substrate **101** and the first inorganic layer **110**. The first electrode **131** and the shielding metal layer **131-1** may be formed of the same conductive layer. Then, a metal oxide semiconductor **121** may be disposed on the first inorganic layer **110**, and a second inorganic layer **112** and a conductive layer (not shown) may be respectively disposed on the first inorganic layer **110**, the conductive layer may be patterned to obtain a second electrode **132** and the gate electrode **122**, the second electrode **132** and the gate electrode **122** may be formed of the same conductive layer. Later, as described above, the thin film transistor **120**, the blue organic light emitting diode **150**, the inorganic insulating layer and/or the organic insulating layer are completed on the substrate **101**. In this embodiment, please refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (please refer to FIG. 1C) is aligned and attached to the substrate **101** of the third embodiment, the display device **100** of the third embodiment as shown in FIG. 3 may be obtained.

[0041] FIG. 4A and FIG. 4B are schematic diagrams of the cross-sectional structures of the display device **100** in different manufacturing stages according to the fourth embodiment of the present disclosure. Compared with the first embodiment, the main difference of the fourth embodiment resides in the inclusion of a fourth inorganic layer **134** and a fifth inorganic layer **135** in the fourth embodiment and in the different configuration of the stack structure of the storage capacitor **130**, so similar structures will not be elaborated again. For example, in the fourth embodiment, the fourth inorganic layer **134** and the fifth inorganic layer **135** may be disposed between the gate electrode **122** and the first organic layer **140**, and the second electrode **132** of the storage capacitor **130** may be selectively disposed between the fourth inorganic layer **134** and the fifth inorganic layer **135**, and the first electrode **131** of the storage capacitor **130** may be disposed between the substrate **101** and the first inorganic layer **110**. In the fourth embodiment, the first inorganic layer **110**, the second inorganic layer **112** and/or the fourth inorganic layer **134** may be disposed between the first electrode **131** and the second electrode **132** to serve as the dielectric layer of the storage capacitor **130**, but it is not limited thereto. The fourth inorganic layer **134** and the fifth inorganic layer **135** may be disposed between the gate electrode **122** and the source electrode **124**/drain electrode **123**. The materials of the fourth inorganic layer **134** and/or the fifth inorganic layer **135** may be similar to the materials of the first inorganic layer **110** or the second inorganic layer **112**. In some embodiments, the positions of the second electrode **132** and the first electrode **131** may be interchanged. In other words, the first electrode **131** of the storage capacitor **130** may be disposed between the fourth inorganic layer **134** and the fifth inorganic layer **135**, and the second electrode **131** of the storage capacitor **130** may be disposed between the substrate **101** and the first inorganic layer **110**.

[0042] The manufacturing process of the display device **100** of the fourth embodiment will be briefly described as follows, but it is not limited thereto. Please refer to FIG. 4A, a conductive layer (not shown) may be provided on the substrate **101**, and the conductive layer may be patterned to obtain the first electrode **131** and the shielding metal layer **131-1**. Next, the first inorganic layer **110** may be disposed on the first electrode **131** and the shielding metal layer **131-1**, the first electrode **131** and the shielding metal layer **131-1** may be disposed between the substrate **101** and the first inorganic layer **110**. Then, a metal oxide semiconductor **121** may be disposed on the first inorganic layer **110**, a second inorganic layer **112** and a conductive layer (not shown) may be respectively disposed on the first inorganic layer **110**, and the conductive layer may be patterned to obtain a gate electrode **122**. Later, a fourth inorganic layer **134** may be disposed on the second inorganic layer **112** and/or the gate electrode **122**. Next, a conductive layer (not shown) may be disposed on the fourth inorganic layer **134**, and the conductive layer may be patterned to obtain a second electrode **132**. The second electrode **132** is not the same layer as other electrodes (such as the gate electrode **122**, the source electrode **124** or the drain electrode **123**), it may improve the design flexibility of the second electrode **132**. For example, the design of the second electrode **132** may be adjusted to

facilitate the adjustment of the capacitance value of the storage capacitor **130**. Next, a fifth inorganic layer **135** may be disposed on the second electrode **132** and/or the fourth inorganic layer **134**, and the fifth inorganic layer **135** may be patterned to obtain the first conductive via **114** and the second conductive via **115**. The first conductive via **114** and the second conductive via **115** may penetrate the fifth inorganic layer **135**, the fourth inorganic layer **134**, and/or the second inorganic layer **112**, but it is not limited thereto. Then, the source electrode **124** and the drain electrode **123** may be respectively filled in the first conductive via **114** and into the second conductive via **115** to complete the formation of the thin film transistor **120** . . . In this embodiment, please refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (please refer to FIG. **1C**) is aligned and attached to the substrate **101** of the fourth embodiment, the display device **100** of the fourth embodiment as shown in FIG. **4B** may be obtained.

[0043] FIG. **5** is a schematic diagram of a cross-sectional structure of a display device **100** according to a fifth embodiment of the present disclosure. Compared with the fourth embodiment, the main difference of the fifth embodiment resides in the different configuration of the stack structure of the storage capacitor **130**, so similar structures will not be elaborated again. For example, the first electrode **131** of the storage capacitor **130** of the fifth embodiment may be disposed between the second inorganic layer **112** and the fourth inorganic layer **134**, and the second electrode **132** of the storage capacitor **130** may be disposed between the fourth inorganic layer **134** and the fifth inorganic layer **135**. The first electrode **131** and the gate electrode **122** may be formed of the same conductive layer. This configuration may simplify the manufacturing process. The fourth inorganic layer **134** of the fifth embodiment may be disposed between the first electrode **131** and the second electrode **132** to serve as a dielectric layer of the storage capacitor **130**, but it is not limited thereto. In some embodiments, the positions of the second electrode **132** and the first electrode **131** may be interchanged. In other words, the second electrode **132** may be disposed between the second inorganic layer **112** and the fourth inorganic layer **134**, and the first electrode **131** of the storage capacitor **130** may be disposed between the fourth inorganic layer **134** and the fifth inorganic layer **135**.

[0044] The manufacturing process of the display device **100** of the fifth embodiment will be briefly described as follows, but it is not limited thereto. Please refer to FIG. **5**, a first inorganic layer **110** and a metal oxide semiconductor **121** are provided on the substrate **101**. Next, a second inorganic layer **112** and a conductive layer (not shown) may be disposed on the first inorganic layer **110**, and the conductive layer may be patterned to obtain the first electrode **131** and the gate electrode **122**. Then, a fourth inorganic layer **134** may be disposed on the second inorganic layer **112**, the first electrode **131** and the gate electrode **122**. Later, a conductive layer (not shown) may be disposed on the fourth inorganic layer **134**, and the conductive layer may be patterned to obtain the second electrode **132**. Since the second electrode **132** is not formed together with other electrodes (such as the gate electrode **122**, the source electrode **124** or the drain electrode **123**), it may facilitate the design flexibility of the second electrode **132**. Next, a fifth inorganic layer **135** may be disposed on the fourth inorganic layer **134**, and the fifth inorganic layer **135** may be patterned to obtain the first conductive via **114** and/or the second conductive via **115**. The first conductive via **114** and/or the second conductive via **115** may penetrate the fifth inorganic layer **135**, the fourth inorganic layer **134** and/or the second inorganic layer **112**, and then the source electrode **124** and the drain electrode **123** may be respectively disposed in the first conductive via **114** and the second conductive via **115** to complete the fabrication of the thin film transistor **120**. In this embodiment, please refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (please refer to FIG. **1C**) is aligned and attached to the substrate **101** of the fifth embodiment, the display device **100** of the fifth embodiment as shown in FIG. **5** may be obtained.

[0045] FIG. **6** is a schematic diagram of a cross-sectional structure of a display device **100**

according to a sixth embodiment of the present disclosure. Compared with the first embodiment, the main difference of the sixth embodiment resides in the different configuration of the stack structure of the storage capacitor **130**, so similar structures will not be elaborated again. For example, the first electrode **131** of the storage capacitor **130** of the sixth embodiment may be disposed between the fourth inorganic layer **134** and the fifth inorganic layer **135**, and the second electrode **132** may be disposed between the fifth inorganic layer **135** and the first organic layer **140**. The second electrode **132** may be formed of the same conductive layer as the source electrode **124** and the drain electrode **123**, but it is not limited thereto. The fifth inorganic layer **135** may be disposed between the first electrode **131** and the second electrode to serve as a dielectric layer of the storage capacitor **130**. In some embodiments, the positions of the first electrode **131** and the second electrode **132** may be interchanged. In other words, the second electrode **132** may be disposed between the fourth inorganic layer **134** and the fifth inorganic layer **135**, and the first electrode **131** may be disposed between the fifth inorganic layer **135** and the first organic layer **140**. [0046] The manufacturing process of the display device **100** of the sixth embodiment will be briefly described as follows, but it is not limited thereto. First, please refer to the illustration in FIG. **6**, a first inorganic layer **110**, a metal oxide semiconductor **121** and a second inorganic layer **112** may be provided on the substrate **101**. Next, a gate electrode **122** may be provided on the second inorganic layer **112**. Later, a fourth inorganic layer **134** may be provided on the second inorganic layer **112** and the gate electrode **122**. Then, a conductive layer (not shown) may be disposed on the fourth inorganic layer **134**, and the conductive layer may be patterned to obtain the first electrode **131**. Because the first electrode **131** disposed on the fourth inorganic layer **134** is not formed together with other electrodes (for example, the gate electrode **122**, the source electrode **124** or the drain electrode **123**), it may facilitate the design flexibility of the first electrode **131**. Later, a fifth inorganic layer **135** may be provided on the fourth inorganic layer **134** and the first electrode **131**. Next, the fifth inorganic layer **135** may be patterned to obtain a first conductive via **114** and/or a second conductive via **115**. The first conductive via **114** and/or the second conductive via **115** may penetrate the fifth inorganic layer **135**, the fourth inorganic layer **134** and/or the second inorganic layer **112**. Then, a conductive layer may be disposed on the fifth inorganic layer **135**, and then the conductive layer may be patterned to obtain the second electrode **132**, the source electrode **124** and the drain electrode **123**. The second electrode **132**, the source electrode **124**, and/or the drain electrode **123** may be formed of the same conductive layer. In this embodiment, please refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (please refer to FIG. **1C**) is aligned and attached to the substrate **101** of the sixth embodiment, the display device **100** of the sixth embodiment as shown in FIG. **6** may be obtained.

[0047] The present disclosure further proposes an auxiliary electrode for use in the laminated structure of the above-mentioned display device to help reduce the problems of the display device of insufficient driving voltage or of IR drop. Various embodiments of the auxiliary electrode for used in the laminated structures of the display device are described as follows.

[0048] Please refer to FIG. **1B** and FIG. **1C**. An auxiliary electrode **155** may be optionally added to the first embodiment. As shown in FIG. **1B**, the auxiliary electrode **155** may be disposed on the cathode **152**. The cathode **152** may be electrically connected to the auxiliary electrode **155**, and the auxiliary electrode **155** may selectively contact the cathode **152** directly or indirectly. The thickness of the auxiliary electrode **155** may be greater than the thickness of the cathode **152** to improve the problem of the IR drop caused by insufficient driving voltage of the display device **100**. The above-mentioned comparison between the thickness of the auxiliary electrode **155** and the thickness of the cathode **152** may be measured in a cross-sectional image. For example, the thickness of the auxiliary electrode **155** may be obtained by measuring the maximum thickness of the auxiliary electrode **155** which overlaps the cathode **152** under the same cross-sectional image, the thickness of the cathode **152** may be obtained by measuring the maximum thickness of the cathode **152**

which overlaps the auxiliary electrode **155**. In some embodiments, the materials of the auxiliary electrode **155** may include a low electric resistance material. In some embodiments, the materials of the auxiliary electrode **155** may be made of a material including copper, aluminum, silver or an alloy, but it is not limited thereto. In some embodiments, the materials of the auxiliary electrode **155** may include nanosilver, nanosilver paste, conductive carbon material, other suitable materials or a combination thereof, but it is not limited thereto. The auxiliary electrode **155** may be formed by etching or transferring the conductive layer, but it is not limited thereto. In some embodiments (as shown in FIG. **1B**), the auxiliary electrode **155** may overlap the thin film transistor **120** and/or the second organic layer **142** in the top view direction **D1**. In some embodiments (as shown in FIG. **1B**), the auxiliary electrode **155** may be disposed on the second organic layer **142**. In some embodiments, in the top view direction **D1**, the auxiliary electrode **155** may not overlap the blue organic light emitting diode **150** and/or the storage capacitor **130** to reduce the shielding of the light coming from the blue organic light emitting diode **150** caused by the auxiliary electrode **155**, or to make the auxiliary electrode **155** less likely interfere with the storage capacitor **130**.

[0049] FIG. **7** is a schematic diagram of the cross-sectional structure of the display device **100** in the manufacturing stages according to the seventh embodiment of the present disclosure. Compared with the first embodiment (please refer to FIG. **1B** and FIG. **1C**), the main difference of the seventh embodiment resides in the different position of the auxiliary electrode **155**. As shown in FIG. **7**, the second organic layer **142** may be disposed between the blue organic light emitting layer **150** and the first organic layer **140**, and the auxiliary electrode **155** may be disposed between the second organic layer **142** and the first organic layer **140**. Specifically speaking, please refer to the descriptions of the above first embodiment, the first organic layer **140** may be provided and the first organic layer **140** may be patterned to form the contact via **141**. Next, a conductive layer (not shown) may be disposed on the first organic layer **140**, and the conductive layer may be selectively filled in the contact via **141**, and then the conductive layer may be patterned to obtain the anode **151** of the blue organic light emitting diode **150** and/or the auxiliary electrode **155**. The auxiliary electrode **155** and/or the anode **151** may be disposed on the first organic layer **140** and located between the second organic layer **142** and the first organic layer **140**. In other words, the anode **151** and the auxiliary electrode **155** may be formed of the same conductive layer, and this configuration may be beneficial to simplify the manufacturing process. Then, the second organic layer **142** and the blue organic light emitting layer **153** may be formed, the second organic layer **142** may be disposed between the blue organic light emitting layer **153** and the first organic layer **140**. The second organic layer **142** may be used as a pixel defining layer or a planarization layer. Later, an auxiliary electrode via **156** which penetrates the blue organic light emitting layer **153** and/or the second organic layer **142** is formed, the auxiliary electrode via **156** may expose a portion of the auxiliary electrode **155**. In some embodiments, the auxiliary electrode via **156** may be formed by laser drilling, etching or other methods, but it is not limited thereto. Afterwards, the cathode **152** of the blue organic light emitting diode **150** may be formed. A portion of the cathode **152** may selectively fill in the auxiliary electrode via **156**, the cathode **152** may be electrically connected to the auxiliary electrode **155** through the auxiliary electrode via **156**, but it is not limited thereto. In some embodiments, the conductive material **157** in the auxiliary electrode via **156** may be the same as or different from the cathode **152**. In other embodiments, a conductive material **157** may fill in the auxiliary electrode via **156**, the cathode **152** may be electrically connected to the auxiliary electrode **155** through the conductive material **157**. The materials of the cathode **152** and/or the conductive material **157** may include a transparent conductive material, silver paste, electric conductive glue, other suitable materials or a combination thereof, but it is not limited thereto.

[0050] In some embodiments, the auxiliary electrode **155** may overlap the thin film transistor **120** or the second organic layer **142** in the top view direction **D1**. In some embodiments, in the top view direction **D1**, the auxiliary electrode **155** may not overlap the blue organic light emitting diode **150** or the storage capacitor **130** with the advantages as described above. In this embodiment, please

refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (refer to FIG. **1C**) is aligned and attached to the substrate **101** of the seventh embodiment, the display device **100** of the seventh embodiment shown in FIG. **7** may be obtained.

[0051] FIG. **8** is a schematic diagram of a cross-sectional structure of the display device **100** in the manufacturing stages according to the eighth embodiment of the present disclosure. Compared with the first embodiment (please refer to FIG. **1B** and FIG. **1C**), the main difference of the eighth embodiment resides in the different position of the auxiliary electrode **155**. As shown in FIG. **8**, the second inorganic layer **112** may be disposed between the gate electrode **122** and the metal oxide semiconductor **121**, the third inorganic layer **113** may be disposed between the first organic layer **140** and the second inorganic layer **112**, and the auxiliary electrode **155** may be disposed between the third inorganic layer **113** and the first organic layer **140**. Specifically speaking, please refer to the descriptions of the above first embodiment, a conductive layer (not shown) may be provided on the third inorganic layer **113**, and the conductive layer (not shown) may be patterned to respectively obtain the auxiliary electrode **155**, the second electrode **132**, the source electrode **124** and/or the drain electrode **123**. In other words, the auxiliary electrode **155**, the second electrode **132**, the source electrode **124** and/or the drain electrode **123** may be formed of the same conductive layer. This configuration is beneficial to simplify the manufacturing process. In addition, as shown in FIG. **8**, the layers which the auxiliary electrode via **156** penetrates may be different when the auxiliary electrode **155**, the second electrode **132**, the source electrode **124** and/or the drain electrode **123** may be formed of the same conductive layer. For example in this embodiment, the auxiliary electrode via **156** may penetrate the blue organic light emitting layer **153**, the second organic layer **142**, and the first organic layer **140**, the auxiliary electrode via **156** may expose a portion of the auxiliary electrode **155**. In some embodiments, a conductive material **157** may fill in the auxiliary electrode via **156**, the cathode **152** may be electrically connected to the auxiliary electrode **155** by the conductive material **157**. In some embodiments, the conductive material **157** in the auxiliary electrode via **156** may be the same as or different from that of the cathode **152**. In this embodiment, please refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (please refer to FIG. **1C**) is aligned and attached to the substrate **101** of the eighth embodiment, the display device **100** of the eighth embodiment as shown in FIG. **8** may be obtained.

[0052] FIG. **9** is a schematic diagram of the cross-sectional structure of the display device **100** in the manufacturing stages according to the ninth embodiment of the present disclosure. Compared with the first embodiment (please refer to FIG. **1B** and FIG. **1C**), the main difference of the ninth embodiment resides in the different position of the auxiliary electrode **155**. As shown in FIG. **9**, the auxiliary electrode **155** may be disposed between the second inorganic layer **112** and the third inorganic layer **113**. Specifically speaking, please refer to the descriptions of the above first embodiment, a first conductive layer (not shown) is provided on the second inorganic layer **112**, and the first conductive layer is patterned to respectively obtain the auxiliary electrode **155**, the first electrode **131** and/or the gate electrode **122**. In other words, the auxiliary electrode **155**, the first electrode **131** and/or the gate electrode **122** may be formed of the same conductive layer, and this configuration may be beneficial to simplify the manufacturing process. In addition, as shown in FIG. **9**, the layers which the auxiliary electrode via **156** penetrates may be different when the auxiliary electrode **155**, the first electrode **131** and/or the gate electrode **122** are formed of the same conductive layer. For example in this embodiment, the auxiliary electrode via **156** may penetrate the blue organic light emitting layer **153**, the second organic layer **142**, the first organic layer **140** and/or the third inorganic layer **113**, the auxiliary electrode via **156** may expose a portion of the auxiliary electrode **155**. In some embodiments, a conductive material **157** may fill in the auxiliary electrode via **156**, the cathode **152** may be electrically connected to the auxiliary electrode **155** by the conductive material **157**. In some embodiments, the conductive material **157** filled in the

auxiliary electrode via **156** may be the same as or different from that of the cathode **152**. In this embodiment, please refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (please refer to FIG. **1C**) is aligned and attached to the substrate **101** of the ninth embodiment, the display device **100** of the ninth embodiment as shown in FIG. **9** may be obtained.

[0053] FIG. **10** is a schematic diagram of the cross-sectional structure of the display device **100** in the manufacturing stages according to the tenth embodiment of the present disclosure. Compared with the first embodiment (please refer to FIG. **1B** and FIG. **1C**), the main difference of the tenth embodiment resides in the different position of the auxiliary electrode **155**. As shown in FIG. **10**, the auxiliary electrode **155** may be disposed between the substrate **101** and the first inorganic layer **140**. Specifically speaking, please refer to the descriptions of the above first embodiment, a conductive layer (not shown) may be provided on the substrate **101**, and the conductive layer may be patterned to respectively obtain the auxiliary electrode **155** and/or the shielding metal layer **131-1**. In other words, the auxiliary electrode **155** and/or the shielding metal layer **131-1** may be formed of the same conductive layer, and this configuration may be beneficial to simplify the manufacturing process. In some embodiments, the shielding metal layer **131-1** may be used to help block or shield light coming from the bottom side of the substrate **101**, or to reduce the effects of the backside light on the thin film transistor **120**, or to reduce the damages of the elements of the display device **100** caused by static electricity. In some embodiments (not shown), the shielding metal layer **131-1** and the auxiliary electrode **155** may be selectively connected to or separated from each other. In addition, as shown in FIG. **10**, the layers which the auxiliary electrode via **156** penetrates may be different when the auxiliary electrode **155** and the shielding metal layer **131-1** are formed of the same conductive layer. For example, the auxiliary electrode via **156** may penetrate the blue organic light emitting layer **153**, the second organic layer **142**, the first organic layer **140**, the third inorganic layer **113**, the second inorganic layer **112** and/or the first inorganic layer **110**, the auxiliary electrode via **156** may expose a portion of the auxiliary electrode **155**. In some embodiments, the conductive material **157** filled in the auxiliary electrode via **156** may be the same as or different from the cathode **152**. In other embodiments (not shown), a conductive material **157** may fill in the auxiliary electrode via **156**, the cathode **152** may be electrically connected to the auxiliary electrode **155** by the conductive material **157**. In this embodiment, please refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (please refer to FIG. **1C**) is aligned and attached to the substrate **101** of the tenth embodiment, the display device **100** of the tenth embodiment as shown in FIG. **10** may be obtained.

[0054] FIG. **11** is a schematic diagram of the cross-sectional structure of the display device **100** in the manufacturing stages according to the eleventh embodiment of the present disclosure. Compared with the first embodiment (please refer to FIG. **1B** and FIG. **1C**), the main difference of the eleventh embodiment resides in the different position of the auxiliary electrode **155**. As shown in FIG. **11**, the fourth inorganic layer **134** and the fifth inorganic layer **135** may be disposed between the gate electrode **122** and the first organic layer **140**, the auxiliary electrode **155** may be disposed between the fourth inorganic layer **134** and the fifth inorganic layer **135**. The auxiliary electrode **155** arranged between the fourth inorganic layer **134** and the fifth inorganic layer **135** may be not disposed together with other electrodes (such as the gate electrode **122**, the source electrode **124** or the drain electrode **123**) to facilitate the design flexibility of the auxiliary electrode **155**. In addition, as shown in FIG. **11**, the layers which the auxiliary electrode via **156** penetrates may be different when the auxiliary electrode **155** is disposed between the fourth inorganic layer **134** and the fifth inorganic layer **135**. For example, the auxiliary electrode via **156** may penetrate the blue organic light emitting layer **153**, the second organic layer **142**, the first organic layer **140** and/or the fifth inorganic layer **135**, the auxiliary electrode via **156** may expose a portion of the auxiliary electrode **155**. In some embodiments, the conductive material **157** filled in the auxiliary

electrode via **156** may be the same as or different from the cathode **152**. In other embodiments (not shown), a conductive material **157** may fill in the auxiliary electrode via **156**, the cathode **152** may be electrically connected to the auxiliary electrode **155** by the conductive material **157**. In this embodiment, please refer to the above embodiments for the procedures and conditions of other material layers, and they will not be elaborated again. After the second substrate structure **102** (please refer to FIG. **1C**) is aligned and attached to the substrate **101** of the eleventh embodiment, the display device **100** of the eleventh embodiment shown in FIG. **11** may be obtained. In this embodiment, the second electrode **132** of the storage capacitor **130** may be disposed on the fifth inorganic layer **135**, and the fourth inorganic layer **134** and/or the fifth inorganic layer **135** may be disposed between the second electrode **132** and the first electrode **131** to serve as the dielectric layer of the storage capacitor **130**, but it is not limited thereto.

[0055] It should be noted that the above-mentioned auxiliary electrode via **156** may be formed in a continuous or segmented manner. When the auxiliary electrode via **156** is formed in a segmented manner, it may be formed by multiple laser or etching steps, for example. In other words, the auxiliary electrode via **156** may be formed in a collection of multiple segmented via holes (not shown). Similarly, the conductive material **157** filled in the auxiliary electrode via **156** may also be filled in a continuous or segmented manner. It should be noted that, in the top view direction **D1** (that is, the normal direction of the substrate **101**), the auxiliary electrode in the above embodiments may not overlap the storage capacitor **130** and/or the thin film transistor **120**. In this configuration, the interference between the storage capacitor **130** and the auxiliary electrode **155** may be reduced to less likely affect the function of the storage capacitor. In some embodiments, the first electrode **131** is electrically connected to the gate electrode of the thin film transistor, and the second electrode **132** may be electrically connected to the source electrode, but it is not limited thereto. In other embodiments, the first electrode **131** may be electrically connected to the gate electrode of the thin film transistor, and the second electrode **132** may be electrically connected to the drain electrode. Please refer to the descriptions of FIG. **13A** later. It should be noted that the positions of the second electrode **132** and the first electrode **131** of the storage capacitor **130** in the above embodiments may be optionally interchanged.

[0056] Please continue to refer to FIG. **12**. FIG. **12** is a schematic diagram of the cross-sectional structure of the display device **100** including a display area and a non-display area according to a twelfth embodiment of the present disclosure. As shown in FIG. **12**, the display device **100** may include an auxiliary electrode **155** disposed in the display area **105** and/or an auxiliary electrode **155'** disposed in the non-display area **106**. The auxiliary electrode **155** may be electrically connected to the auxiliary electrode **155'**, but it is not limited thereto. In some embodiments, the non-display area **106** may be adjacent to the display area **105**, there may be an external conductive pad provided in the non-display area **106** for the connection to an external circuit. In some embodiments, the display area **105** may be defined by the area which surrounds all blue organic light emitting layer **153**, but it is not limited thereto.

[0057] In some embodiments, the auxiliary electrode **155** and the auxiliary electrode **155'** may be selectively electrically connected with each other via some conductive layers, conductive pads and/or via holes. For example, the auxiliary electrode **155** is connected with the auxiliary electrode **155'** via the conductive material **157** filled in the auxiliary electrode via **156**, a portion of the cathode **152**, the conductive portion **152'** (for example, other portions of the same conductive layer as the cathode **152**), the connecting portion **158**, the conductive portion **117** (such as other parts of the same conductive layer as the anode **151**), other conductive layers and/or via holes, but it is not limited thereto, thereby increasing the conductive paths of the cathode **152**, the auxiliary electrode **155** and the auxiliary electrode **155'** to reduce the electric resistance of the cathode **152** or to improve the problem of the IR drop caused by insufficient driving voltage. In some embodiments, the auxiliary electrode **155** may be electrically connected to the conductive pad **159** via the auxiliary electrode **155'**. The conductive pad **159** may be used to connect a circuit board (not

shown) or a chip (not shown), but it is not limited thereto. In some embodiments, the conductive pad **159** may be formed of a conductive layer, and the auxiliary electrode **155** and/or the auxiliary electrode **155'** may be formed by the same conductive layer, but it is not limited thereto. In some embodiments, the conductive portion **152'** may be in direct contact with the connection portion **158** to form an electric connection, the conductive portion **152'** may be electrically connected to the conductive portion **117** via the connection portion **158**, thereby electrically connecting the auxiliary electrode **155** and the auxiliary electrode **155'**, but it is not limited thereto. In other embodiments (not shown), the electric connection between the conductive portion **152'** and the conductive portion **117** through a conductive material may be possible after the formation of a via hole (not shown) which is filled with the conductive material (not shown), the conductive portion **152'** may be electrically connected to the conductive portion **117**, but it is not limited thereto. As mentioned above, the design of the configuration of the conductive portion **152'**, the connecting portion **158**, the conductive portion **117** and/or the auxiliary electrode **155'** in the non-display area **106** may facilitate the repair of the circuit, but it is not limited thereto. In some embodiments, the first sealing layer **160** may be provided on the conductive portion **152'**, the connecting portion **158** and/or the conductive portion **117** to reduce the damage or the risk of water and oxygen penetration of the conductive portion **152'**, the connecting portion **158**, the conductive portion **117** and/or other elements provided under the first sealing layer **160**. It should be noted that, the auxiliary electrode **155** and/or the auxiliary electrode **155'** may be electrically connected to the conductive pad **159** in other cross-sectional structure although it is not illustrated in FIG. **12**.

[0058] Please continue to refer to FIG. **13A** and FIG. **13B**. FIG. **13A** and FIG. **13B** are schematic diagrams of equivalent circuits of the display device **100** according to various embodiments of the present disclosure. FIG. **13A** illustrates a schematic diagram of an NMOS type circuit of the display device, and FIG. **13B** illustrates a schematic diagram of a PMOS type circuit of the display device. FIG. **13A** and FIG. **13B** may respectively show three transistors, such as a first transistor **210**, a second transistor **220**, a third transistor **230** (corresponding to the aforementioned thin film transistor **120**) and/or a storage capacitor **240**, but it is not limited thereto. In other embodiments, the number of transistors and/or capacitors may be increased or decreased according to requirements, and other circuit elements may be selectively added. In some embodiments, the first transistor **210** may include a gate **211**, a source **212** and a drain **213**; the second transistor **220** may include a gate **221**, a source **222** and a drain **223**; the third transistor **230** may include a gate **231**, a source **232** and a drain **233**; the storage capacitor **240** includes a first electrode **241** and a second electrode **242**, but it is not limited thereto. In FIG. **13A**, the gate **211** of the first transistor **210** may be electrically connected to the gate line GL, the source **212** of the first transistor **210** may be electrically connected to the data line DL. The source **222** of the second transistor **220** may be electrically connected to the power terminal C (such as ELVDD, but not limited to this). The gate **231** of the third transistor **230** may be electrically connected to the drain **213** of the first transistor **210**, the source **232** of the third transistor **230** may be electrically connected to the drain **223** of the second transistor **220**, the drain electrode **233** of the third transistor **230** may be electrically connected to the anode **151** of the blue organic light emitting diode **150**, the cathode **152** of the blue organic light emitting diode **150** may be electrically connected to the power terminal C' (such as ELVSS, but not limited to this), but it is not limited thereto. The connection relationship between the components may be adjusted according to practice of the circuit. In some embodiments, the first electrode **241** of the storage capacitor **240** may be electrically connected to the gate electrode **231** of the third transistor **230** and/or to the drain electrode **213** of the first transistor **210**, but it is not limited thereto. In some embodiments, the second electrode **242** of the storage capacitor **240** may be electrically connected to the drain electrode **233** of the third transistor **230**, but it is not limited thereto.

[0059] The electrical connection shown in FIG. **13B** is slightly different from the electrical connection shown in FIG. **13A**. The difference is that the electrical connection of one electrode of

the storage capacitor **240** is different. For example, the first electrode **241** of the storage capacitor **240** may be electrically connected to the drain **213** of the first transistor **210** and/or the gate **231** of the third transistor **230**, the second electrode **242** of the storage capacitor **240** may be electrically connected to the drain **223** of the second transistor **220** and/or to the source **232** of the third transistor **230**, but it is not limited thereto.

[0060] This disclosure proposes a variety of possible embodiments. In some embodiments, a configuration may simplify the manufacturing process when the first electrode and/or the second electrode of the storage capacitor and other electrodes of the display device (for example the gate electrode, the drain electrode, the source electrode or the shielding metal layer) are formed of the same conductive layer. In some embodiments, it may facilitate the design flexibility of the first electrode and/or the second electrode when the first electrode and/or the second electrode of the storage capacitor and other electrodes (for example the gate electrode, the drain electrode, the source electrode or the shielding metal layer) of the display device are formed of different conductive layers.

[0061] The present disclosure also proposes an auxiliary electrode integrated into the stack structure of the display device to reduce the problem of insufficient driving voltage or IR drop. In some embodiments, the design of the auxiliary electrode does not overlap the blue organic light emitting diode **150** and/or the storage capacitor **130** to reduce the shielding of the light emitted from the blue organic light emitting diode **150** caused by the auxiliary electrode **155**, or to reduce the opportunity of the auxiliary electrode **155** interfering with the storage capacitor **130**. In some embodiments, a configuration may simplify the manufacturing process when the auxiliary electrode **155** is formed of the same conductive layer as other electrodes of the display device (for example the gate electrode, the drain electrode, the source electrode or the shielding metal layer). In some embodiments, it may facilitate the design flexibility of the auxiliary electrode **155** when the auxiliary electrode **155** is formed of a conductive layer which is different from that of other electrodes of the display device (for example the gate electrode, the drain electrode, the source electrode, or the shielding metal layer).

[0062] Those skilled in the art will readily observe that numerous modifications and alterations of the device and method may be made while retaining the teachings of the disclosure. Accordingly, the above disclosure should be construed as limited only by the metes and bounds of the appended claims.

Claims

1. A display device, having a display area and a non-display area, comprising: a substrate; a first inorganic layer disposed on the substrate; a transistor disposed on the first inorganic layer, comprising a semiconductor, a first electrode overlapping the semiconductor, and a second electrode electrically connected with the semiconductor; a first organic layer disposed on the transistor, comprising a contact via; a light emitting diode comprising an anode, a cathode, and a light emitting layer disposed therebetween, wherein the light emitting layer is electrically connected with the anode and the cathode, and the anode is electrically connected with the second electrode through the contact via; a first sealing layer disposed on the light emitting diode; a first conductor disposed between the substrate and the first sealing layer and electrically connected to the light emitting diode; and a second conductor disposed on the substrate; wherein the first conductor is disposed in the display area, the second conductor is disposed in the non-display area, and the first conductor is electrically connected to the second conductor.
2. The display device of claim 1, wherein the first conductor is electrically connected to the cathode through a via.
3. The display device of claim 2, wherein a side wall of the via is in contact with the light emitting layer, and a portion of the cathode fills in the via.

- 4.** The display device of claim 2, wherein the first conductor is disposed between the first organic layer and the first sealing layer.
- 5.** The display device of claim 4, wherein the first conductor and the anode are formed of a same layer.
- 6.** The display device of claim 2, further comprising a third inorganic layer disposed between the first electrode and the second electrode, and the first conductor is disposed between the third inorganic layer and the first organic layer.
- 7.** The display device of claim 1, wherein the first conductor and the second conductor are formed of a same layer.
- 8.** The display device of claim 1, wherein a thickness of the first conductor is greater than a thickness of the cathode.
- 9.** The display device of claim 1, further comprising a conductive portion disposed in the non-display area, wherein the conductive portion and the cathode are formed of a same layer.
- 10.** The display device of claim 1, further comprising a second organic layer disposed on the first organic layer, wherein the second organic layer overlaps the first conductor.
- 11.** The display device of claim 10, wherein the second organic layer comprises a pixel definition layer.
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